1	Highly Efficient Photoelectron Emission from Stable Low-Work-Function Surfaces
2	Using Organic Bases
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17	ABSTRACT
18	Photocathodes based on alkali metals such as cesium (Cs) exhibit high quantum efficiency (QE) owing
19	to their low work functions (WFs). However, their poor stability and short lifetimes under vacuum
20	conditions limit their practical application. In this study, we demonstrate that modifying electrodes
21	with phenanthroline derivatives achieves ultra-low WFs of 2.2 eV while significantly enhancing
22	stability compared to Cs under both high vacuum (~ $10^{-5}$ Pa) and ultra-high vacuum (~ $10^{-8}$ Pa)
23	conditions. Notably, 4,7-bis(1-pyrrolidinyl)-1,10-phenanthroline exhibited greater stability than Cs
24	and achieved more than twice the QE of Cs in the $2.7-3.5$ eV photon energy range, without relying on
25	negative electron affinity structures. These findings demonstrate the potential of organic low-WF
26	materials as alternatives to alkali metals for photocathode applications, offering extended
27	photoemission lifetimes under less stringent vacuum conditions.
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30	Photocathodes serve as fundamental components in various applications, such as the first cathode
31	of a photomultiplier tube, electron source for radio-frequency electron guns, and equipment in
32	synchrotron radiation facilities <sup>1–3</sup> . Photocathodes are broadly classified into metal photocathodes (e.g.,

gallium arsenide (GaAs)).<sup>4</sup> Material choices are guided by factors such as their quantum efficiency
 (QE) as a function of light wavelength, operational lifetime, response speed, and required cathode

36 current.

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copper, magnesium, and alkali metals) and semiconductor photocathodes (e.g., cesium telluride and

High photoelectron emission efficiency is required for photocathodes; thus, materials with low work functions (WF), such as alkali metals, are widely used. However, achieving both low WF and high stability remains a significant challenge. Cesium (Cs), one of the lowest known WFs (~2 eV), has been extensively studied for photocathode applications.<sup>5–7</sup> In particular, negative electron affinity (NEA) structures based on GaAs surfaces modified with Cs, which exhibit high QE in the visible light region, have been the subject of intensive research in recent years.<sup>4,8–10</sup>

However, Cs-based photocathodes have serious problems, such as being usable only in ultrahigh 7 8 vacuum (UHV) and extremely limited operational lifetimes. These limitations are due to the high 9 chemical reactivity of Cs surfaces, which readily increases its WF when exposed to residual gases such as oxygen, moisture, and carbon dioxide.<sup>11</sup> To suppress this reactivity, an extremely high vacuum 10 11 of approximately  $10^{-9}$  Pa is required; however, studies on NEA GaAs photocathodes show that even 12 under such stringent conditions, their QE can halve in approximately 1 h.<sup>12</sup> In other words, although a low-WF surface is suitable for a photocathode, stability, and low WF are in a tradeoff relationship, 13 and achieving both is challenging. To address these problems, various research efforts have been 14 15 conducted recently to extend the lifetime of photocathodes. One method involves the use of p-doped 16 gallium nitride (GaN), whose wider bandgap allows for a stable NEA surface, providing four times 17 the lifetime of GaAs <sup>12–14</sup>. The other involves developing Cs-free GaN photocathodes with a stepwise 18 controlled doping concentration to achieve both 10% QE and high stability.<sup>15</sup> Although these efforts 19 have achieved some success in extending the lifetime of NEA photocathodes, stable long-term 20 performance remains difficult even in extremely high vacuum. Therefore, advancing photocathode 21 technology necessitates the development of low-WF surfaces that combine high photoelectron 22 emission efficiency with robust stability.

Low-WF materials are crucial not only in photocathodes but also in various devices such as light-23 emitting diodes and solar cells made of organics, perovskites, and quantum dots.<sup>16–19</sup> In recent years, 24 low-WF materials using oxides, polymers, and organic molecules have been developed.<sup>16,17,19-22</sup> For 25 26 instance, zirconium oxide, which is widely used as a Schottky emitter material exhibits a WF of 2.7 27 eV <sup>23</sup>. Polyethyleneimine (PEI) is a polymer that is widely used as a cathode material in organic lightemitting diodes (OLEDs) and organic photovoltaics.<sup>16</sup> The WF was 3.1 eV when formed on a zinc 28 29 oxide (ZnO) surface. In contrast, the WF of aluminum (Al) and ZnO surfaces (~ 4 eV) can be 30 controlled in the range of approximately 3-2 eV using phenanthroline (Phen) derivatives and strong organic bases.<sup>20–22,24</sup> This is because the coordination reaction at the metal–organic interface can 31 32 generate a substantial WF change of more than 2 eV. These low WF electrodes modified with organic 33 materials exhibit high electron injection properties, and OLEDs using these electrodes emit light at 34 extremely low applied voltages. Furthermore, dark spot formation on the emissive surface is 35 significantly suppressed compared to alkali-metal-based OLEDs, leading to enhanced operational stability even in environments where oxygen and moisture can penetrate. Generally, organic molecules 36

contribute to surface stability because they lack dangling bonds, making them less prone to oxidation.
Therefore, low-WF electrodes modified with these organic materials are more stable against residual
gases in vacuum than alkali-metal electrodes, potentially leading to dramatically improved
photocathode lifetimes. However, reports on the stability of organic low-WF surfaces and their actual
photoemission efficiency under light irradiation, which is crucial for photocathode applications, are
currently unavailable.

7 In this study, we demonstrated that electrodes modified with Phen derivatives achieve WFs ranging 8 from 3.0 to 2.2 eV and exhibit remarkable stability and photoelectron emission efficiency. The stability 9 and photoemission properties of the Phen-modified electrodes were compared with those of Cs. Under high-vacuum (HV,  $\sim 10^{-5}$  Pa) conditions, the WF of Cs increased by approximately 0.4 eV over 100 10 11 min, whereas the increase for all the Phen-modified electrodes was less than 0.1 eV. The QE of 4,7-12 bis(1-Pyrrolidinyl)-1,10-phenanthroline (p-Pyrrd-Phen)-modified electrode was more than twice that 13 of Cs in the 2.7–3.5 eV photon energy range. The photoelectron energy distribution of p-Pyrrd-Phen, 14 which showed the highest QE, revealed that high QE could be achieved without relying on NEA 15 structures. The identification of low-WF organic materials suitable for photocathode applications is a 16 significant advancement, expanding surface modification possibilities and offering a promising path 17 toward more stable, longer-lifetime photocathodes operable under low vacuum conditions.

18 The Phen derivatives: p-Pyrrd-Phen, 4,7-diphenyl1,10-phenanthroline (BPhen), and 2,9-19 Dimethyl-4,7-diphenyl-1,10-phenanthroline (bathocuproine, BCP) (Fig. 1(a)), were provided by 20 Nippon Shokubai Co., Ltd. These materials were deposited onto a 1.0-nm-thick layer of Al (NILACO: 21 purity 99.99 %) or silver (Ag, NILACO: purity 99.99 %) that had been deposited on an indium tin 22 oxide (ITO) substrate to a thickness of 3.0 nm. Low-WF surfaces can be produced using the 23 coordination reaction between the Phen derivatives and metals. Several metal substrates, including 24 ITO, were prepared, and Phen derivatives were deposited on each substrate to verify that the 25 coordination strength depends on the metal species. An alkaline dispenser (SAES Getters S.p. A: 26 CS/NF/3.9/12 FT10+10) was used to directly deposit Cs onto an ITO substrate. Isopropanol, acetone, 27 and a UV ozone cleaner (SEN LIGHT Corporation: SSP16-110) were used to clean the ITO substrates. 28 The deposition rates of the Phen derivatives were approximately 1.0 Å/s, more than 2.0 Å/s for Al, 29 and 0.3 Å/s for Cs. During vacuum deposition, WF measurements were performed using a homemade 30 Rotary Kelvin Probe (RKP) under HV conditions.<sup>25</sup> The WF of the reference electrode made of stainless steel (SUS304, mainly iron, chromium ~18%, nickel ~8%) was 4.43 eV. When measured by 31 32 RKP, the working pressure was maintained between  $7 \times 10^{-5}$  and  $1 \times 10^{-4}$  Pa. A Tektronix KEITHLEY 33 6430 sub-femtoampere source measuring unit and photomultiplier tubes (Hamamatsu Photonics: R376, 34 R6836) were used to conduct QE measurements in the reflection mode. The photon flux was calculated 35 by considering the viewport transmittance, gain, and spectral sensitivity of the photomultiplier tubes. A deuterium lamp (Hamamatsu Photonics: L1835, 150 W) and a xenon lamp (Ushio: UXL-500D, 500 36

1 W) were used as light sources, and the emitted light was monochromatized using a zero-dispersion 2 double monochromator (Bunkoukeiki: BIP-M25-GTM). Ultraviolet photoelectron spectroscopy 3 (UPS) was performed by irradiating a sample with light with a photon energy of 7.7 eV. Electrons emitted perpendicularly from the sample surface were collected using an electrostatic hemispherical 4 5 analyzer (PSP: RESOLVE120). After depositing the sample in a deposition chamber maintained at 8  $\times 10^{-6}$  Pa, the photoelectron emission properties were determined in a measuring chamber maintained 6 at  $6 \times 10^{-8}$  Pa and applying -10 V on the sample. Further details on the experimental setup have 7 8 been described in previous studies.<sup>25,26</sup>

9 Figure 1(b) shows the RKP measurement results of the WF during the deposition of the Cs and 10 Phen derivatives under HV conditions. During Cs deposition, the WF time-dependent variation and 11 instability were observed by measuring it with RKP during film growth. Figure 1(b) shows an unstable 12 decrease in WF upon Cs deposition on ITO (blue line). The WF reached 2.29 eV, which was 13 immediately increased. In contrast, the WFs of the Phen derivatives vacuum-deposited on Al-coated 14 ITO, BCP (green line), BPhen (blue line), and p-Pyrrd-Phen (red line) decreased immediately to 3.08, 15 2.80, and 2.27 eV, respectively, and thereafter remained highly stable. A similar trend was observed 16 for p-Pyrrd-Phen deposited directly on ITO (violet line) and Ag-coated ITO (black line), resulting in 17 WFs of 3.93 and 2.37 eV, respectively. Among the substrates tested, Al exhibited the lowest WF. This 18 could be due to different interactions between the metals and the p-Pyrrd-Phen, which arise from 19 variations in the atomic radii and outer-shell orbitals of the surface metal atoms. The instability 20 observed during the deposition of Cs (Fig. 1(b)) is attributed to the chemical reactions and the physical 21 adsorption of residual gases such as water.<sup>27</sup> In addition, alternating surface contamination and film 22 formation may occur because pure Cs have low cohesive energy and does not form multilayers at room 23 temperature  $^{28}$ . As a result, the WF of Cs in Fig. 1(b) fluctuated and reached its minimum value even 24 during deposition. Therefore, the low WF surface formation process for Phen derivatives is more stable 25 and reproducible than that of Cs.

26 Figure 2(a)-(c) shows the stabilities of WF after deposition under HV and UHV conditions. Under 27 HV conditions, the WF shift from the end of deposition ( $\Delta$ WF) for Cs (blue line) fluctuated and 28 increased by up to 0.4 eV after 100 min (Fig. 2(a)). In contrast, the Phen derivatives remained highly 29 stable, with an increase of less than 0.1 eV. A different experimental setup than that used for Fig. 2(a) 30 was used to conduct stability evaluations under UHV conditions (Figs. 2(b) and (c)). The WFs of Cs 31 (blue line), BCP (green line), BPhen (orange line), and p-Pyrrd-Phen (red line) were 2.15, 3.03, 2.89, 32 and 2.18 eV, respectively, immediately after deposition under UHV conditions (Fig. 2(b)). After 1000 33 min, the WF of Cs increased by more than 0.1 eV, whereas that of Phen derivatives increased by less 34 than 0.05 eV (Fig. 2(c)). As a metal, Cs is highly reactive because of its low WF and ionization 35 potential (IP). In contrast, organic molecules generally exhibit large band gaps and, despite having low 36

electron-donating capabilities similar to those of Cs because their IPs are approximately 5 eV. Both the formation of an interface dipole and chemical bonding between the substrate and molecules are responsible for the reduction in WF induced by the Phen derivatives.<sup>21</sup> This difference in the mechanism of WF reduction is the reason for the excellent WF stability of the Phen derivatives (Figs. 2(a)–(c)). Thus, an electrode modified with p-Pyrrd-Phen and Al offers significantly higher stability under both HV and UHV conditions, while displaying a WF as low as that of Cs.

7 Figure 3(a) shows the QE measurement results under UHV conditions. The vertical axis represents 8 logarithmic QE, and the horizontal axis corresponds to the incident photon energy. The QEs of p-9 Pyrrd-Phen (red line), BPhen (orange line), BCP (green line), and Cs (blue line) (Fig. 3(a)), were 10 measured by photocurrent detection using a source measuring unit. In contrast, the QE curve of ITO 11 (black line) was determined by normalizing its photoelectron yield spectrum, which was measured 12 with high sensitivity using a photomultiplier tube that was calibrated using the QE value of the photon 13 energy of 7.7 eV that was obtained by photocurrent measurement. The OE of ITO at other photon 14 energies was too low to be measured using the source measuring unit; hence, this method was required. 15 A correlation between WF (Fig. 2(b)) and QE emission threshold values (Fig. 3(a)) was observed when 16 comparing the Phen derivatives. Furthermore, high OEs were obtained for Cs and the Phen derivatives 17 in all photon energy ranges above their respective WFs. This indicates that a low WF is essential for 18 high QE. As shown in Fig. 3(a), the QE of Cs decreased relative to that of p-Pyrrd-Phen at photon 19 energies above 5.4 eV, most likely because of an increase in the WF during the measurement. During the QE measurements, the WF of Cs increased by 0.04 eV. Although the WFs of p-Pyrrd-Phen and Cs 20 21 in Fig. 2(b) were similar, the QE of p-Pyrrd-Phen was more than twice that of Cs in the photon energy 22 range of 2.7-3.5 eV. Above 3.5 eV, the QE of Cs increased, approaching that of p-Pyrrd-Phen. To 23 further investigate the QE characteristics, the density of states (DOS) was determined using UPS; the 24 results are shown in Fig. 3(b). The horizontal axis represents the binding energy relative to the vacuum 25 level. According to previous studies, the underlying Al and in-gap states formed between the molecules 26 and substrate originate from the shallow-energy structure observed near the Fermi level in Phen derivatives.<sup>21,29–32</sup> In addition, the relative intensity of the DOS of Cs and p-Pyrrd-Phen reversed at a 27 28 binding energy of 3.3 eV, indicating that p-Pyrrd-Phen has a shallower energy structure than Cs. The 29 QE differences between p-Pyrrd-Phen and Cs are probably due to variations in DOS. Furthermore, 30 differences in the optical reflectivity and photoionization cross-section may contribute to the higher 31 QE of p-Pyrrd-Phen. Generally, metals with free electrons exhibit higher reflectivity than organic 32 molecules with localized electrons. Moreover, the outer-shell electron of Cs is in the 6s orbital, which 33 has a relatively lower photoionization cross-section (0.1-0.2 Mb) under low-energy photon excitation.<sup>33</sup> In Fig. 3(a), a shoulder-like structure is observed at approximately 3.8 eV in all the spectra. 34 35 The photon energy itself, rather than the DOS, is responsible for this increase in QE because the UPS 36 data shown in Fig. 3(b) does not contain any similar feature. Previous studies have shown that ITO

exhibits an absorption onset at 3.2 eV, which aligns well with the observed QE features.<sup>34</sup> This implies
 that photon absorption in the ITO substrate could be due to the increase in QE. Overall, these results
 demonstrate that p-Pyrrd-Phen exhibits superior QE characteristics compared to Cs because of the
 combination of its WF and DOS.

5 To further investigate the superior photoemission properties of p-Pyrrd-Phen, photoelectron emission spectroscopy was used with various photon energies. Figures 4(a)-(c) show the 6 photoelectron emission spectra obtained at incident photon energies ranging from 2.4 eV to 5.0 eV. 7 8 The vertical axis represents the photoelectron intensity normalized to the incident photon flux, and the 9 horizontal axis corresponds to the kinetic energy of the emitted electrons. The spectral width increased 10 proportionally with photon energy. This relationship is not straightforward in NEA photocathodes such 11 as GaAs because electrons are tunneled through the surface potential barrier.<sup>35,36</sup> This indicates that 12 photoemission from p-Pyrrd-Phen follows the conventional three-step model rather than NEA. 13 Notably, even in the absence of NEA, such high photoemission efficiency can be achieved (Fig. 3(a)). 14 A secondary electron peak begins to emerge at an incident photon energy of 3.4 eV and increases 15 significantly with higher photon energies, according to the shape of each spectrum (Figs. 4(a)-(c)). 16 The threshold energy of 3.4 eV is consistent with the onset of the structure commonly observed in all 17 the spectra shown in Fig. 3(a). Furthermore, the spectrum obtained using an ITO substrate exhibited a 18 more intense secondary electron peak than that obtained using highly oriented pyrolytic graphite 19 (HOPG), according to a comparison of UPS spectra for BPhen on Al with HOPG substrates 20 (Supplementary Fig. 1). These results demonstrate that the photoelectrons generated within the ITO 21 substrate are emitted as secondary electrons into the vacuum. This indicates that selecting an 22 appropriate substrate that facilitates a strong internal photoelectric effect can enhance the QE even 23 when designing a photocathode using p-Pyrrd-Phen.

24 In conclusion, we demonstrated that the Phen derivatives can form stable low-WF surfaces with 25 excellent photoelectron emission properties, making them highly promising materials for photocathode surface modification. The WFs of p-Pyrrd-Phen and BPhen exhibit lower WFs than Cs 26 27 and are more stable under HV conditions. In addition, even under UHV, p-Pyrrd-Phen maintained a 28 lower WF than Cs and a QE that was more than twice as high as Cs in the 2.7–3.5 eV photon energy 29 range. Furthermore, high QE was achieved without the use of NEA structures. The identification of 30 this low-WF organic material is a significant advancement, expanding the range of viable 31 photocathode surface modification materials to include organic molecules. The proposed design also 32 introduces the potential for long-lifetime photocathodes to be operable in lower vacuum conditions. 33 Future studies should combine Phen derivatives with substrates exhibiting strong internal 34 photoelectric effect efficiency and GaAs or GaN, which can also form NEA surfaces.

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1	SUPPLEMENTARY MATERIAL
2	See the supplementary material for UPS spectra measured using photon energy light for BPhen
3	deposited on Al with different substrates: ITO and HOPG.
4	
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8	
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11	The authors have no conflicts to disclose.
12	
13	Author Contributions
14	Manato Tateno: Conceptualization (equal); Data curation (lead); Formal analysis (lead);
15	Investigation (lead); Validation (lead); Visualization (lead); Writing - original draft (lead); Writing -
16	review & editing (equal). Miyu Moriyama: Data curation (lead); Investigation (lead). Masahiro
17	Ohara: Data curation (equal); Formal analysis (equal); Methodology (lead); Resources (lead);
18	Software (lead); Writing - review & editing (equal). Katsuyuki Morii: Conceptualization (lead);
19	Resources (lead); Writing - review & editing (equal). Munchiro Hasegawa: Conceptualization
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21	administration (lead); Resources (lead); Supervision (lead); Validation (lead); Writing - review &
22	editing (lead). Hirohiko Fukagawa: Conceptualization (lead); Funding acquisition (lead); Project
23	administration (lead); Resources (lead); Supervision (lead); Validation (lead); Writing - review &
24	editing (lead).
25	
26	DATA AVAILABILITY
27	The data that support the findings of this study are available from the corresponding author upon
28	reasonable request.
29	
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## 1 Figures

2



4 FIG. 1. (a) Molecule structures of phenanthroline (Phen) derivatives (BCP, BPhen, p-Pyrrd-Phen). (b)

5 Work functions during deposition with Phen derivatives and Cs measured using a rotary Kelvin probe

- 6 under high vacuum conditions. The arrows represent the deposition endpoints.
- 7



1

FIG. 2. Stabilities of low work function (WF) surfaces of phenanthroline derivatives (BCP, BPhen, p-Pyrrd-Phen) and Cs. (a) WF shift ( $\Delta$ WF) relative to the end of deposition under high vacuum

4 conditions. (b) WF, measured using ultraviolet photoelectron spectroscopy under ultra-high vacuum

- 5 (UHV) conditions. (c)  $\Delta$ WF under UHV conditions.
- 6



1

2 FIG. 3. (a) Quantum efficiency of low work function surfaces with Cs, ITO, and phenanthroline (Phen)

3 derivatives (BCP, BPhen, p-Pyrrd-Phen). (b) Ultraviolet photoelectron spectra of Cs and Phen

- 4 derivatives, measured using 7.7 eV photon energy.
- 5

- 1
- 2 FIG. 4. Photoelectron emission spectra of
- 3 p-Pyrrd-Phen deposited on Al-coated
- 4 ITO, measured using photon energies in
- 5 the ranges of (a) 2.4–3.0, (b) 3.1–4.0, and
- 6 (c) 4.1–5.0 eV.
- 7

